

Docket No.: TCP-005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

001569545  
PATENT  
149201 27 FEB 2006

In re Application of

Shojiro KOMATSU et al

U.S. Patent Application No.: -----

Filed: *herewith*

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Confirmation No.

Group Art Unit: -----

For: FILM OF SP<sup>3</sup>-BONDED BORON NITRIDE HAVING A SELF-ORGANIZED  
SURFACE TEXTURE CAPABLE OF PROMOTING FIELD ELECTRON  
EMISSION, METHOD FOR PRODUCING THE SAME AND USE THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:


In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

Please note this is a PCT application in the entry of the National Phase in the U.S. and copies of the references cited were transmitted by WIPO. Copies of the foreign search report and the references cited are attached for the Examiner's information. Acknowledgement and consideration of these documents are respectfully requested.

Respectfully submitted,

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